

Site	Search Text	DBs	TimeStamp
1 4	(*5948577* *5691011*).pn.	US-PPGPUB; USPAT; EPO; JPO; DEPARTMENT	2005/01/28 16:32
2 2	(*6373187*).pn.	US-PPGPUB; USPAT; EPO; JPO; DEPARTMENT	2005/01/11 13:29
3 1	"JP 63308920 A"	JPO	2005/01/11 13:36
4 1	"JP 06109912 A"	JPO	2005/01/11 13:37
5 1	"JP 06347637 A"	JPO	2005/01/11 13:38
6 1	"JP 07234314 A"	JPO	2005/01/11 13:39
7 1	"JP 09230127 A"	JPO	2005/01/11 13:39
8 1	"JP 11040354 A"	JPO	2005/01/11 13:44
9 0	"09/423969*.pn."	US-PPGPUB; USPAT; EPO; JPO; DEPARTMENT	2005/01/11 14:10
10 0	"09/423969"	US-PPGPUB; USPAT; EPO; JPO; DEPARTMENT	2005/01/11 14:10
11 4541	(thin adj film) and affinity and substrate and organic and (ito or glass)	US-PPGPUB; USPAT; EPO; JPO; DEPARTMENT	2005/01/28 16:33
12 211	(thin adj film) and affinity and substrate and (organic adj semiconductor) and (ito or glass)	US-PPGPUB; USPAT; EPO; JPO; DEPARTMENT	2005/01/28 16:33
13 174	(thin adj film) and affinity and substrate and (organic adj semiconductor) and (ito or glass) and inorganic	US-PPGPUB; USPAT; EPO; JPO; DEPARTMENT	2005/02/01 16:01
14 65	(thin adj film) and affinity and substrate and (organic adj semiconductor) and (ito or glass) and inorganic and polyimide	US-PPGPUB; USPAT; EPO; JPO; DEPARTMENT	2005/01/28 16:34
15 44	(thin adj film) and affinity and substrate and (organic adj semiconductor) and (ito or glass) and inorganic and polyimide and transistor	US-PPGPUB; USPAT; EPO; JPO; DEPARTMENT	2005/01/28 16:35
16 7	(thin adj film) and substrate and (affinity same (organic adj semiconductor)) and (ito or glass) and inorganic and polyimide and transistor	US-PPGPUB; USPAT; EPO; JPO; DEPARTMENT	2005/02/01 16:01
17 5703	<u>257/40,59,88,89.cccls. 438/29,30,70,99.cccls.</u>	US-PPGPUB; USPAT; EPO; JPO; DEPARTMENT	2005/02/01 16:01
18 174	(thin adj film) and affinity and substrate and (organic adj semiconductor) and (ito or glass) and inorganic	US-PPGPUB; USPAT; EPO; JPO; DEPARTMENT	2005/02/01 16:02
19 43	S17 and S18	US-PPGPUB; USPAT; EPO; JPO; DEPARTMENT	2005/02/01 16:02

EAST 1-11-05